

#2 / IDS
D. B. J. 10-18-01
EL 8 440 49534

Inventor: Haining Yang

Title: Methods of Forming Metal-Comprising Materials and Capacitor
Electrodes; and Capacitor Constructions

Assignee: Micron Technology, Inc.



INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, the Examiner's attention is directed to the references listed on the attached Form PTO-1449 and copies of which are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date:

8/16/01

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Suzanne on Aug. 9, 2001